TLNC Nano Profiler

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Specific alignment, quick calibration and customization makes the TLNC Nano profiler ideal tool for industrial and production metrology use.

Customization for non-flat components is possible and upon customer request. Other customization is also possible upon request.

FEATURES

- Quick & easy non-contact surface profile measurement
- No scanning optical profiler (single-shot operation)
- Optical component diameter up to 80mm or 55mm square (customization for maximized resolution)
- 633nm operational wavelength (other wavelengths upon request)
- Accuracy of down to 200nm
- Dynamic range (max. P-V) up to 100um

